

HE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.:

10/809,205

Filing Date:

March 25, 2004

Applicant:

Toshimitsu HIRAI

Group Art Unit:

1762

Examiner:

Brian K. Talbot

Title:

METHOD OF FORMING A FILM PATTERN ON A

SUBSTRATE BY ARRANGING DROPLETS OF

LIQUID MATERIAL ON THE SUBSTRATE

Attorney Docket:

9319S-000717

Mail Stop RCE Commissioner for Patents P.O. Box 1450 Alexandria, Virginia 22313-1450

AMENDMENT/REPLY

Sir:

In conjunction with Applicant's Request for Continued Examination pursuant to 37 C.F.R. § 1.114 and in response to the Final Office Action mailed November 3, 2006, please amend the application as follows and consider the remarks set forth below. Applicant hereby petitions under the provisions of 37 C.F.R. § 1.136(a) for an extension of time in which to respond to the outstanding Office Action and includes a 64/69/2007 MINILIGET 00000010 503213 fee as set forth in 37 C.F.R. § 1.17(a) with this response for Successful extension of time.

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Amendments to the Claims begin on page 2 of this paper.

Remarks begin on page 8 of this paper.